

<b>Notice of References Cited</b>	Application/Control No. 10/788,754		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner William M. Brewster		Art Unit 2823	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
X	A	US-2004/0248369 a1	12-2004	Wang et al.	438/305
X	B	US-2003/0235966 a1	12-2003	Kim et al.	438/305
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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**FOREIGN PATENT DOCUMENTS**

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